

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Patent Application of:

Jae-Chun HYUN et al.

Application No.: 10/590,113

Confirmation No.: 2095

Filed: August 18, 2006

Art Unit: 2123

For: METHOD FOR SOLVING TRANSIENT  
SOLUTION AND DYNAMICS IN FILM  
BLOWING PROCESS

Examiner: R. Guill

**AMENDMENT UNDER § 1.116**

**MS AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**June 28, 2010**

Sir:

**INTRODUCTORY COMMENTS**

In reply to the Office Action dated March 26, 2010, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 8.